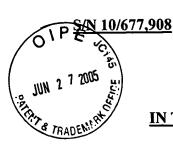


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Oraci ilic i alci ilici i ilici ilic	Application Number	10/677,908	
TRANSMITTAL	Filing Date	October 1, 2003	
FORM	First Named Inventor	Fruhberger, Bernd	
	Art Unit	1744	
	Examiner Name	Not Yet Assigned	
(to be used for all correspondence after initial filing)	Attorney Docket Number		
Total Number of Pages in This Submission	Attorney bocket Number	SCS-1001-UT .	
E	NCLOSURES (Check all	hat apply)	
Document(s)	Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence A Terminal Disclaimer Request for Refund CD, Number of CD(s) Landscape Table on CD	of Appeals Appeal Co (Appeal No Proprietar Status Let	closure(s) (please Identify A ces
Reply to Missing Parts/ Incomplete Application Reply to Missing Parts under 37 CFR 1.52 or 1.53	RE OF APPLICANT, ATTO	RNEY, OR AGENT	
Firm Name Big/Technblogy Law Group	2		
Signature Vail M. Cu			
Printed name Daniel M. Chambers			
Date 25 June 200	5	eg. No. 34,561	
I hereby certify that this correspondence is being sufficient postage as first class mail in an envelopment of the date shown below:	TIFICATE OF TRANSMISS facsimile transmitted to the USPT pe addressed to: Commissioner to	or deposited with the United	d States Postal Service with xandria, VA 22313-1450 on
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Typed or printed name Daniel M. Chamb	ers	Date	25 June 2005)

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

FRUHBERGER, Bernd, et al.

Examiner:

Not Yet Assigned

Serial No.:

10/677,908

Group Art Unit:

1744

Filed:

October 01, 2003

Docket:

SCS-1001-UT

Title:

Dense Thin Film-Based Chemical Sensors and Methods for Making and Using

Same

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir/Madam,

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 et. seq., the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicants respectfully request that this Information Disclosure Statement be entered and the documents listed on the attached Form SB08A be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicants request that a copy of the SB08A form, initialed as being considered by the Examiner, be returned to the Applicants with the next official communication.

The listed documents are being submitted in compliance with 37 CFR § 1.97(b), before the mailing date of the first office action on the merits.

If any fees are due, please contact the undersigned attorney at (858) 350-9690.

Serial No.: 10/677,908

Filing Date: October 1, 2003

Title: Dense Thin Film-Based Chemical Sensor and Methods for Making and Using Same

Page 2 Dkt: SCS-1001-UT

The Examiner is invited to contact the Applicants' Representative at the below-listed telephone number if there are any questions regarding this communication.

	Respectfully-submitted,
Date 25 June 2 es	By Lail M. hund
BioTechnology Law Group	Daniel M. Chambers
658 Marsolan Ave.	Reg. No. 34,561
Solana Beach, CA 92075	
Telephone: (858) 350-9690	
Fax: (858) 350-9691	
Email: dan@biotechnologylawg	roup.com
sufficient postage as first class mail in an envelop VA 22313-1450 on the date shown below.	facsimile transmitted to the USPTO or deposited with the United States Postal Service with the addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria,
25 June , 2005	Signature
	<u>Daniel M. Chambers</u> Printed Name

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Complete if Known Substitute for form 1449A/PTO INFORMATION DISCLOSURE 10/677,908 **Application Number** STATEMENT BY APPLICANT October 1, 2003 **Filing Date First Named Inventor** Fruhberger, Bernd **Group Art Unit** 1744 **Examiner Name** Unknown Attorney Docket No: SCS-1001-UT Sheet 1 of 3

	US PATENT DOCUMENTS				
Examiner Initials *	Cite No. ¹	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines,Where Relevant Passages or Relevant Figures Appear

		FORE	IGN PATENT	DOCUMENTS		
Examiner Initials*	Cite No.¹	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines, Where Relevant Passages or Relevant Figures Appear	T²

	OTHE	R DOCUMENTS NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
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DATE CONSIDERED EXAMINER

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	Group Art Unit	1744	
	Examiner Name	Unknown	
Sheet 2 of 3	Attorney Docket No: S	SCS-1001-UT	

	OTHE	ER DOCUMENTS NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
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